

JCK MEMS/NEMS 2022

The 13th Japan-China-Korea Joint Conference on MEMS/NEMS

16-19 October, 2022, Kagoshima, Japan

Kyushu
CNP



actuators
an Open Access Journal by MDPI

Explore New MEMS Opportunity in Silicon Island "Kyushu".

The selected papers are recommended for

"*Micro/Nano Electromechanical Sensors and Actuators*". A special issue of *Actuators*.

Honorary Chair

➤ Renshi SAWADA (Kyushu University, Japan)

Conference Chair

➤ Norihisa MIKI (Keio University, Japan)

Conference Co-Chairs

➤ Sung-Ho LEE (KITECH, Korea)

➤ Libo ZHAO (Xi'an Jiaotong University, China)



Conference Scope

1. Micro & nano fabrication including 3D printing
2. Micro & nano electronics including flexible electronics
3. Micro & nano sensors & actuators
4. Micro & nano systems
5. Networked microsystems & IoT technologies
6. Materials & device characterization
7. Integration & packaging technologies
8. Modeling & simulation of manufacturing process
9. Others



Important Dates !

Registration Deadline

Presenter: 1st August, 2022

Others: 15th October, 2022

Submission Deadline

10th August, 2022

Visit the website For all the latest Information !

<https://www.jckmemsnems2022.com/>